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(54) Title: PRE-CUTTER AND EDGER MACHINE

(57) Abstract: A pre-cutter or edger machine for processing the periphery of an optic is provided. The pre-cutter or edger machine of the present invention is advantageous in that it provides a machine that eliminates the need to mount the optic on a block, is completely automatic, and has a cycle time of approximately 10 seconds. The machine also is capable of pre-cutting or edging an optic to any of a number of different diameters of shapes with or without the need for traced data. The machine cleans the optic automatically and maintains the edge processing stations substantially free from debris.